



Reviewer's Recognition

The Editor and Editorial Board of the *Journal of Pressure Vessel Technology* would like to thank all of the reviewers for volunteering their expertise and time reviewing manuscripts in 2020. Serving as reviewers for the journal is a critical service necessary to maintain the quality of our publication and to provide the authors with a valuable peer review of their work. Below is a complete list of reviewers for 2020. We would also like to acknowledge three outstanding Reviewers of the Year.

2020 Reviewers of the Year

Yoshio Takagi — Thermal and Nuclear Power Engineering Society, Japan
Atef Mohany — Institute of Technology, University of Ontario, Canada
George E. Varelis — PDL Solutions (Europe) Limited, UK

The Reviewers of the Year Award is given to reviewers who have made an outstanding contribution to the journal in terms of the quantity, quality, and turnaround time of reviews completed during the past 12 months. The prize includes a Wall Plaque, 50 free downloads from the ASME Digital Collection, and a one year free subscription to the journal.

List of Reviewers

O. Abri	X. Chengyu	I. Fujita
R. Adibi-Asl	M. Chevalier	T. Funada
W. Ahmed	Y. Choi	P. Garland
H. Al-Muslim	O. Chopra	M. Gerini Romagnoli
B. Alfredsson	A. Chudnovsky	P. Ghosh
S. Ang	N. Cofie	T. Gilman
A. Antenucci	D. Corritore	B. Glass
N. Arafa	A. Cosham	C. Gong
J. Arnold	S. Cravero	M. Goodarzi
S. Asada	S. Dash	R. Habing
M. Asadi	C. Davies	O. Hamouda
K. Avriithi	C. Davies	K. Hasegawa
B. Azadi-kinetics	W. Dayang	M. Hassan
A. Bandyopadhyay	M. De-Franco	S. Hassan
D. Banerjee	A. Dubov	M. Heinrich
G. Barber	A. Duncan	K. Hojo
F. Berto	S. El Bouzidi	G. Horne
J. Besson	W. El-Dakhkhni	M. Imura
B. Bezensek	E. Elmukashfi	T. Ishikawa
F. Billon	M. Elsharqawy	T. Itoh
J. Bossard	P. Feenstra	H. Jahed
G. Brown	Z. Feng	V. Janzen
W. Brown	M. Ferber	J. Jo
O. Bursi	C. Florio	R. Juergen
X. Chen	B. Frew	J. Kim
W. Cheng	T. Fujioka	S. Kim

Y. Kim
T. Kobayashi
N. Kojima
A. Kolaei
D. Kontoni
S. Kumagai
A. Kumar
V. Lacroix
F. Lai
P. Lam
H. Lan
M. Langthjem
D. Li
S. Limon
N. Lin
P. Lu
W. Lubitz
X. Lv
W. Ma
T. Maeguchi
A. Maekawa
A. Mann
T. Martin
J. Melville
K. Miyazaki
A. Mohany
P. Mohlya
A. Mokhtari
F. Moody
J. Moran
R. Morita
R. Motriuk
P. Moussou
E. Murakami
N. Mureithi
D. Muth
T. Nagashima
I. Nakamura
R. Nascimbene
T. Nicak
Y. Nomura

A. Nonn
J. Norkus
M. Ohata
H. Okada
A. Otani
K. Oyamada
N. Palm
F. Paolacci
Y. Park
J. Parker
S. Patterson
W. Payten
S. Pedrazzini
B. Pellereau
T. Pervez
J. Pietralik
B. Pinheiro
L. Possidente
A. Prada
S. Qamar
H. Qian
A. Ravi Kiran
A. Reich
G. Ricciardi
D. Riznic
J. Rouse
D. Rudland
Y. Saito
C. San Marchi
K. Sato
T. Sawa
T. Sawadogo
M. Schaaf
R. Selker
C. Sessions
V. Shcherbinin
D. Shim
G. Shine
A. Shintani
M. Sivy
A. Smith

B. Smith
M. Spindler
G. Stevens
D. Sun
S. Szávai
T. Tagawa
Y. Takagi
K. Takahashi
M. Takla
H. Thomas
T. Thome
A. Tijsseling
W. Toter
O. Trifonov
S. Tu
A. Uchibori
E. Uckan
M. Uddin
M. Vanrooyen
G. Varelis
A. Varvani-Farahani
Y. Wada
S. Wang
Y. Wang
Y. Wang
B. Wasiluk
D. Watanabe
H. Watanabe
D. Weaver
D. Wei
B. Wiersma
M. Witek
Z. Wu
W. Xiangying
H. Yang
H. Zhang
J. Zhang
J. Zhang
X. Zhu
F. Zou